



PATENT  
ATTORNEY DOCKET NO. 053785-5158

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	
Seok-Woo LEE	)	Confirmation No.: 5713
	)	
Application No.: 10/695,897	)	Group Art Unit: 2811
	)	
Filed: October 30, 2003	)	Examiner: Unassigned
	)	
For: METHOD OF FORMING POLYSILICON	)	<b>Mail Stop Amendment</b>
THIN FILM TRANSISTOR	)	

Commissioner for Patents  
U.S. Patent and Trademark Office  
**Mail Stop Amendment**  
Alexandria, VA 22314

Sir:

**INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)**

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), Applicant brings to the attention of the Examiner the documents listed on the attached PTO-1449. Each item of information contained in this Information Disclosure Statement was first cited in a Search Report from the Korean Patent Office (copy enclosed) in a counterpart foreign application before the mailing date of a first Office Action on the merits. Therefore, no fee is required for filing this Information Disclosure Statement.

A concise explanation of relevance for each of the non-English language documents listed may be ascertained from the English-language translation of their Abstract. Copies of the documents are attached. Applicant respectfully requests that the Examiner consider the listed documents and evidence that consideration by making appropriate notations on the attached form.

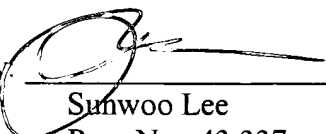
This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that the listed documents are material or constitute "prior art." If it should be determined that the listed documents do not constitute "prior art" under United States law, Applicant reserves the right to present to the Office the relevant facts and law regarding the appropriate status of such documents.

Applicant further reserves the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should any of the documents be applied against the claims of the present application.

**Except** for issue fees payable under 37 C.F.R. §1.18, the Commissioner is hereby authorized by this paper to charge any additional fees during the entire pendency of this application including fees due under 37 C.F.R. §§1.16 and 1.17 which may be required, including any required extension of time fees, or credit any overpayment to Deposit Account No. 50-0310. This paragraph is intended to be a **CONSTRUCTIVE PETITION FOR EXTENSION OF TIME** in accordance with 37 C.F.R. §1.136(a)(3).

Respectfully submitted,

**MORGAN, LEWIS & BOCKIUS LLP**

By:   
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Reg. No. 43,337

Dated: February 16, 2005

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# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

PTO Form 1449

Attorney Docket No.

053785-5158

Application No.:

10/695,897

Applicant: Seok-Woo LEE

Filing Date: October 30, 2003

Group Art Unit: 2811

## U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Sub Class	Filing Date

## FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Sub Class	<u>Translation</u> YES NO	
2001-0052812	06/25/2001	Korea			Abstract	
11-074536	03/16/1999	Japan			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


Examiner

Date Considered

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

SL\XY\fdb

February 16, 2005

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